

#17/F/3/5/00

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on

2/22/2000  
Date of Deposit

Kent E. Genin, Reg. No. 37,834

Name of Applicant, Assignee or  
Registered Representative

Kent E. Genin  
Signature

2/22/2000  
Date of Signature



RECEIVED  
MAR - 3 2000  
TECHNOLOGY CENTER 3700

PATENT  
CASE NO. 7103/30-1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: )  
)  
Homayoun Talieh et al. )  
)  
Serial No.: 08/853,323 ✓ )  
)  
Filed: May 8, 1997 )  
)  
For: LINEAR POLISHER AND )  
METHOD FOR )  
SEMICONDUCTOR WAFER )  
PLANARIZATION )

Examiner: G. Nguyen

Group Art Unit: 3723

**RESPONSE AND AMENDMENT**

Assistant Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In response to the Office Action dated September 21, 1999 please enter the following amendment and consider the following remarks: